

Organizational Chart

- Europe
- Japan
- Korea
- North America
- Taiwan

Last updated: April 29, 2011

SEMI Europe Regional Standards Organization

Co-chairs: Jean-Marie Collard - Solvay Chemicals, Werner Bergholz - Jacobs University of Bremen

Compound Semiconductor Materials Committee

C: R. Bindermann - FCM
C: A. Weber - SiCrystal

EHS Committee

C: B. Planting - ASML
C: open

Photovoltaic Committee

C: L. Fabry - Wacker Chemie
C: H. Aulich - PV Crystalox Solar

Equipment Automation Committee

C: A. Honold - InReCon (I&C, PIC, Metrics)
C: M. Carrubba - Numonyx (I&C, PIC)
C: L. Pfitzner - FhG IISB (Metrics)
VC: F. Petzold - Trustsec (I&C)

Gas & Liquid Chemicals Committee

C: J-M Collard - Solvay Chemicals
C: G. Ferrier - Air Products
VC: G. De Vos - FFEM

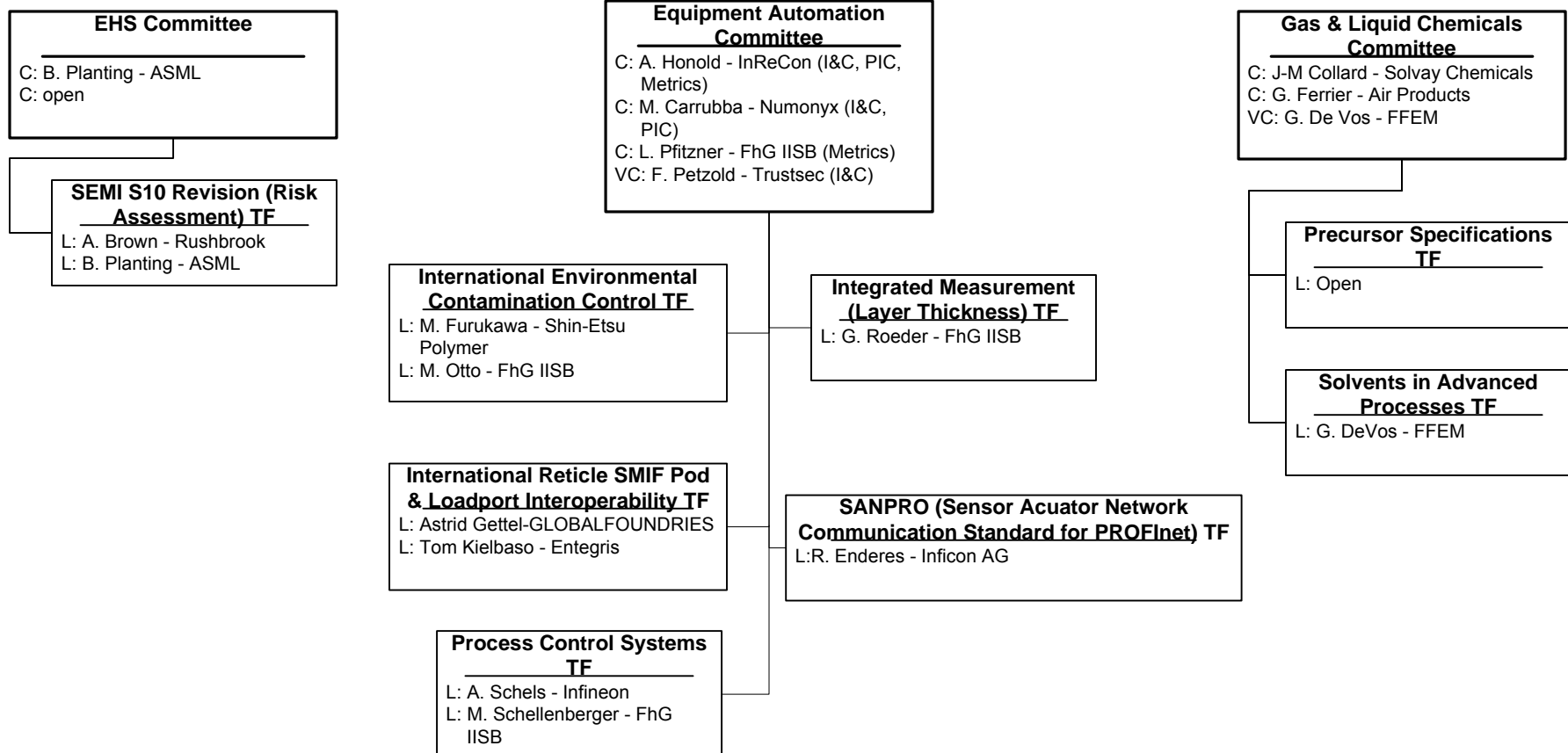
Photovoltaic Automation Committee

C: T. Körner - Q-Cells
C: M. Zenning - Jonas & Redmann
C: E. Teichmann - Peer Group

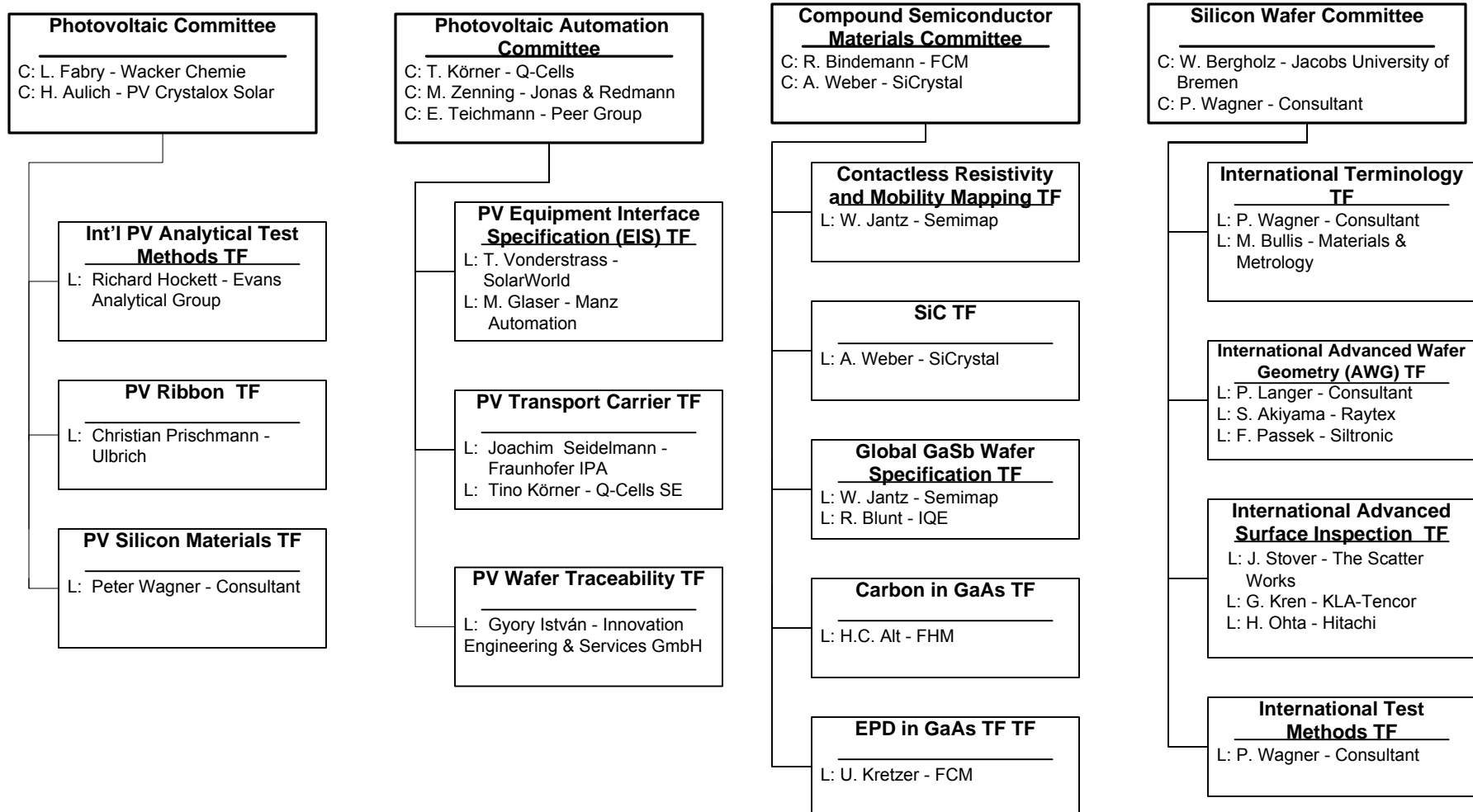
Silicon Wafer Committee

C: W. Bergholz - Jacobs University of Bremen
C: P. Wagner - Consultant

SEMI Europe EHS, Equipment Automation, and Gas & Liquid Chemicals Committees



SEMI Europe PV, PV Automation, Compound Semiconductor and Silicon Wafer Committees



SEMI Japan Regional Standards Organization

Co-Chair: Shigeru Kobayashi - Renesas Technology Co-Chair: Makoto Yamamoto - Muratec Automation
Vice Chair: Supika Mashiro - TEL

Information & Control Committee

C: Mitsune Sakamoto - TEL
C: Takayuki Nishimura - DNS
C: Mitsutoshi Matsuda - Hitachi Kokusai

Physical Interfaces & Carriers Committee

C: Shoji Komatsu - Acteon
C: Tsuyoshi Nagashima - Miraial
C: Tsutomu Okabe - TDK

Metrics Committee

C: Toshio Murakami - Murakami Corporation
C: Mikio Furukawa - Shin-Etsu Polymer

Micropatterning Committee

C: Iwao Higashikawa - Toshiba

Traceability Committee

C: Michio Honma - Renesas Electronics
C: Hirokazu Tsunobuchi - Keyence

Photovoltaic Materials Committee

C: Takashi Ishihara - Mitsubishi Electronics
C: Kazuhiko Kashima - Covalent Materials
C: Masaaki Yamamichi - AIST

Photovoltaic Committee

C: Takashi Ishihara - Mitsubishi Electronics
C: Kazuhiko Kashima - Covalent Materials
C: Masaaki Yamamichi - AIST
C: Terry Asakawa - TEL

Photovoltaic Automation Committee

C: Terry Asakawa - TEL
C: Emi Ishikawa - Atelier Ishikawa

Liquid Chemicals Committee

C: Hiroshi Tomita - Toshiba
C: Kenji Sugimoto - DNS

Packaging Committee

C: Kazunori Kato - AiT
C: Haruo Tabata - Osaka University
C: Yutaka Koma - Advisor

Test Committee

C: Hirofumi Kaga - Renesas Electronics
C: Takashi Umenaga - Teradyne

Environmental Health & Safety Committee

C: Hidetoshi Sakura - Intel
C: Supika Mashiro - TEL
C: Moray Crawford - Hatsuta Seisakusho

Gases & Facilities Committee

C: Hiromichi Enami - Hitachi High-Technologies
C: Isao Suzuki - MKS Japan

Compound Semiconductor Materials Committee

C: Masayoshi Obara - SEH
C: TBD

Silicon Wafer Committee

C: Naoyuki Kawai - Tokyo University
C: Tetsuya Nakai - SUMCO

FPD Factory Automation Committee

C: Yasunobu Otagawa - Daihen
C: Harumichi Hirose - Shibaura Mechatronics

FPD Materials & Components Committee

C: Hisashi Aruga - Seiko Epson
C: Tadahiro Furukawa - Kyodo Printing
C: Yoshihiko Shibahara - FUJIFILM

FPD Mask Committee

C: Atsushi Okazaki - SK-Electronics
C: Kaname Nitobe - HOYA

FPD Metrology Committee

C: Ryoichi Watanabe - Toshiba Mobile Display
C: Yuji Yoda - Otsuka Electronics

Special Groups

Reporting to the JRSC

Standardization Process Integration (SPI)

L: Supika Mahiro - TEL

FPD Coordination Group

L: Yoshitada Nogami - SK Electronics
L: Makoto Yamamoto - Muratec

SEMI Japan PV, PV Materials, and PV Automation Committees

**Photovoltaic Materials
Committee**
C: Takashi Ishihara - Mitsubishi
Electronics
C: Kazuhiko Kashima - Covalent
Materials
C: Masaaki Yamamichi - AIST

Japan PV Materials TF
L: Masaaki Yamamichi - AIST
L: Takashi Ishihara -
Mitsubishi Electronics

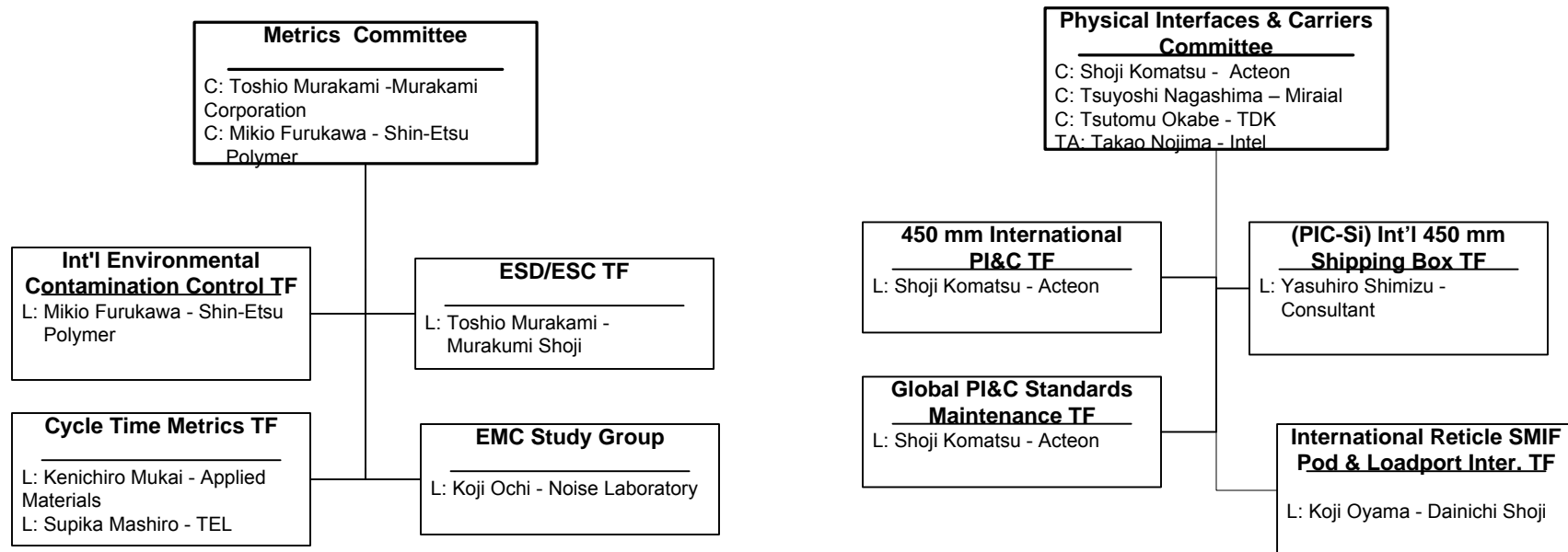
**Photovoltaic Automation
Committee**
C: Emi Ishikawa - Atelier Ishikawa
C: Terry Asakawa - TEL

**PV Equipment Interface
Specification (PV-EIS) TF**
L: Takashi Murakami - TEL
L: Makoto Ishikawa - Nisshinbo
Mechatronics

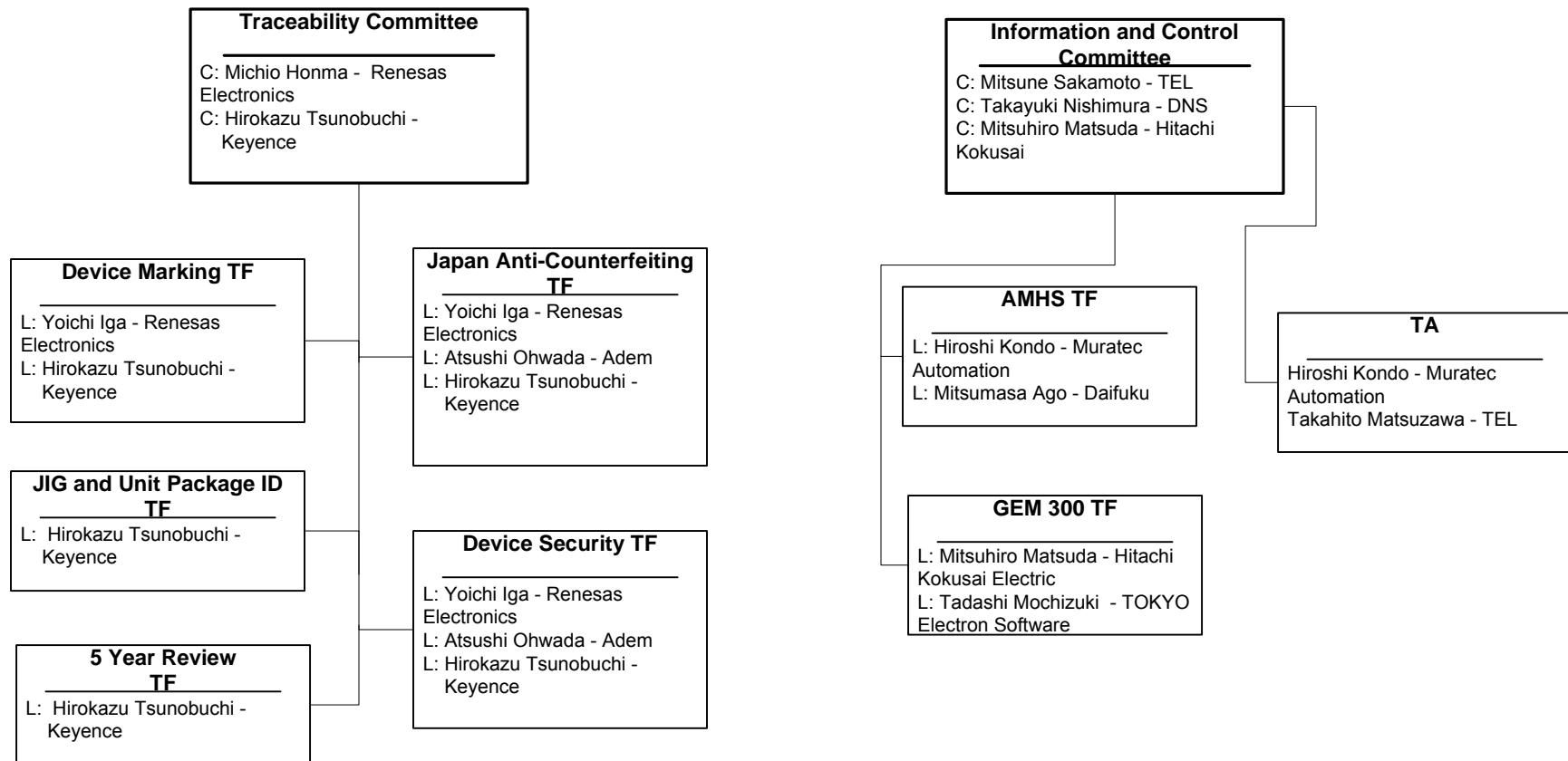
**PV Transport Carrier
TF**
L: Koji Ohyama - DNS
L: Shuichi Inoue - Miraial

Photovoltaic Committee
C: Takashi Ishihara - Mitsubishi
Electronics
C: Kazuhiko Kashima - Covalent
Materials
C: Masaaki Yamamichi - AIST
C: Terry Asakawa - TEL

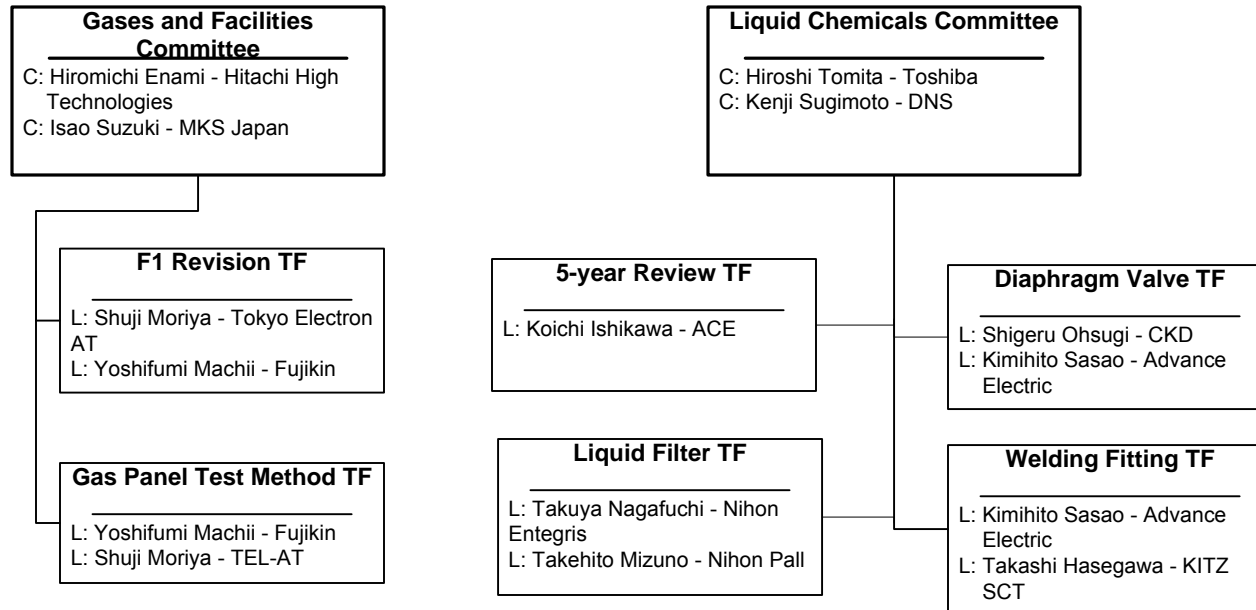
SEMI Japan PI&C and Metrics Committees



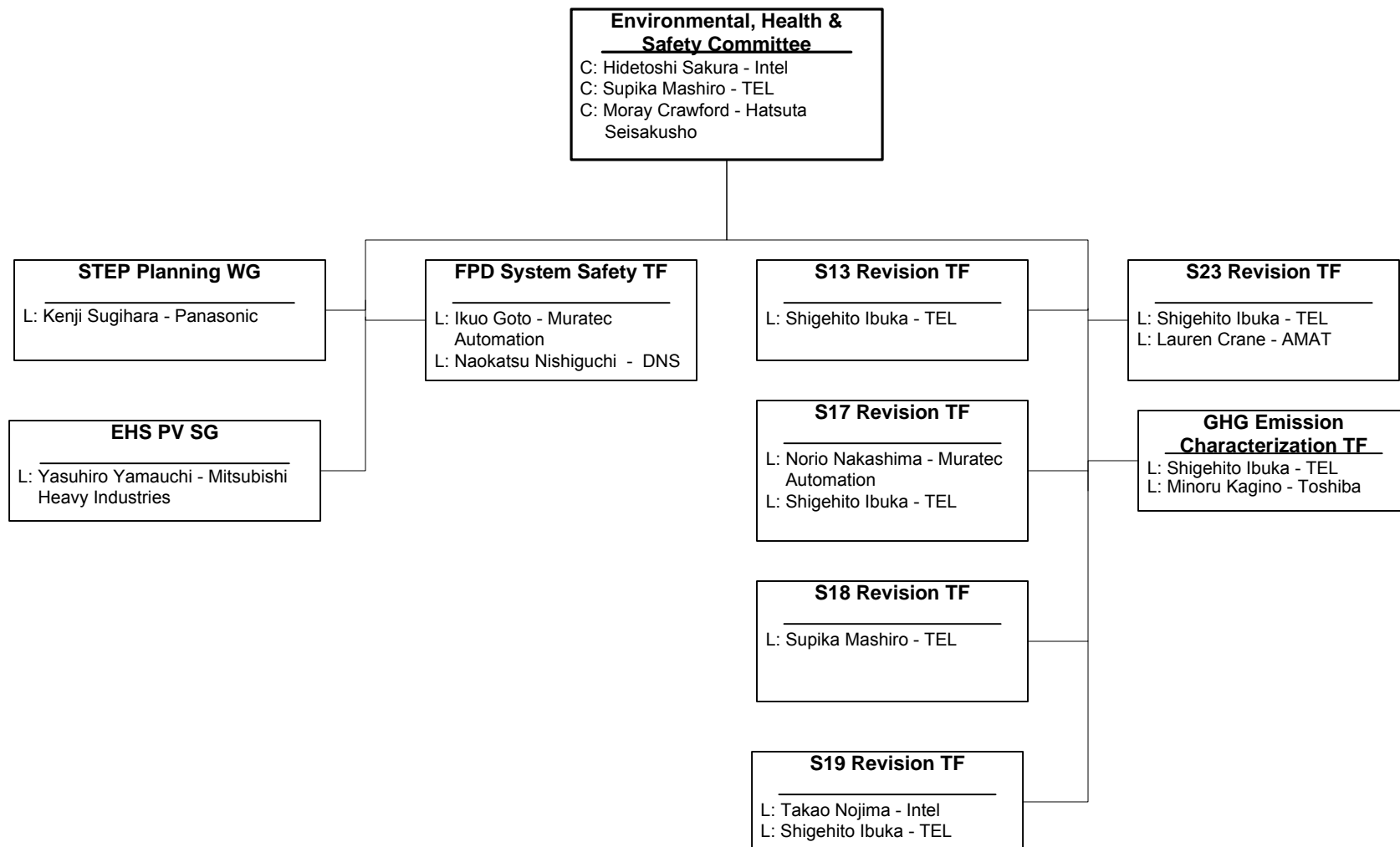
SEMI Japan Information & Control, and Traceability Committees



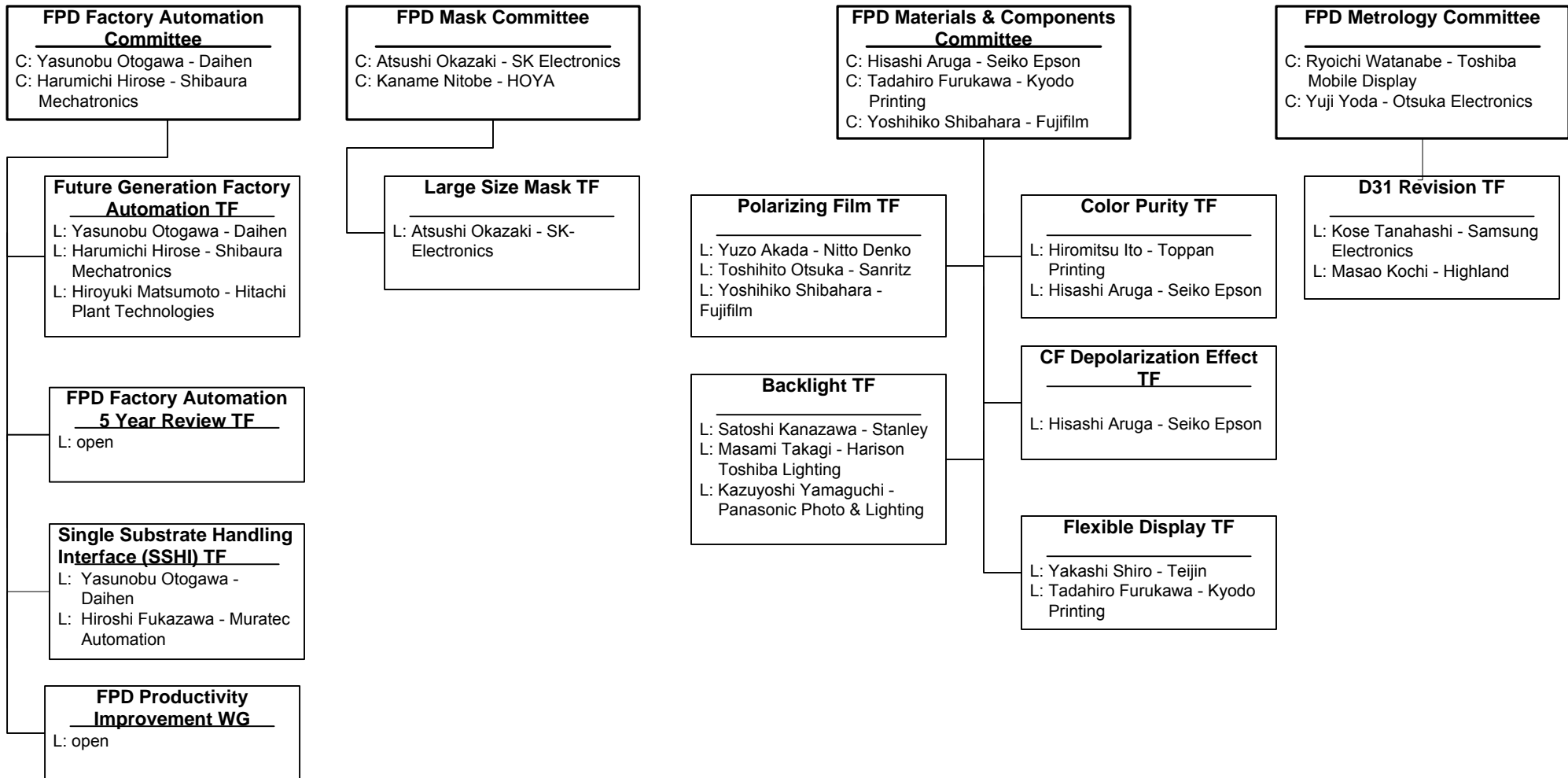
SEMI Japan Gases & Facilities, and Liquid Chemicals Committees



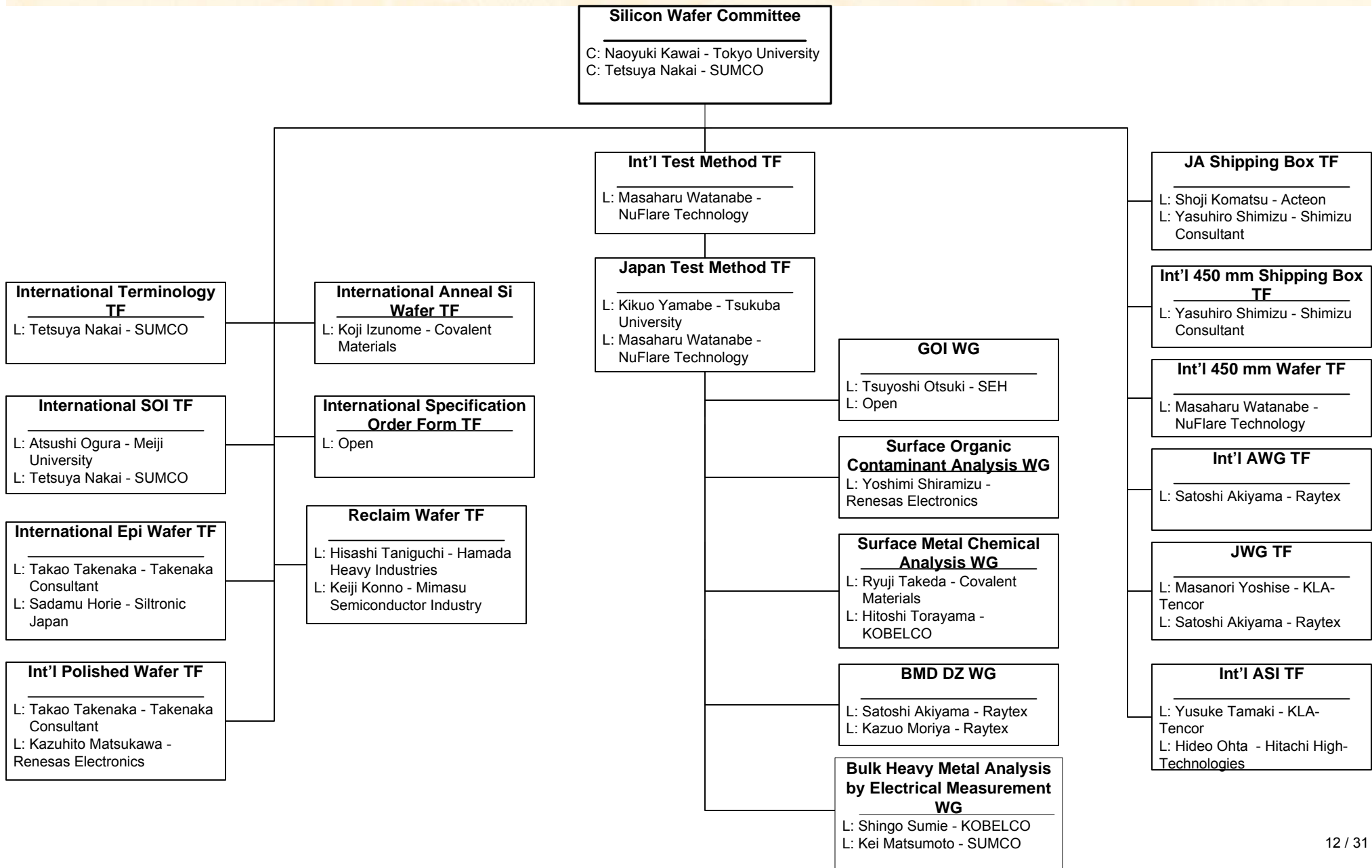
SEMI Japan EHS Committee



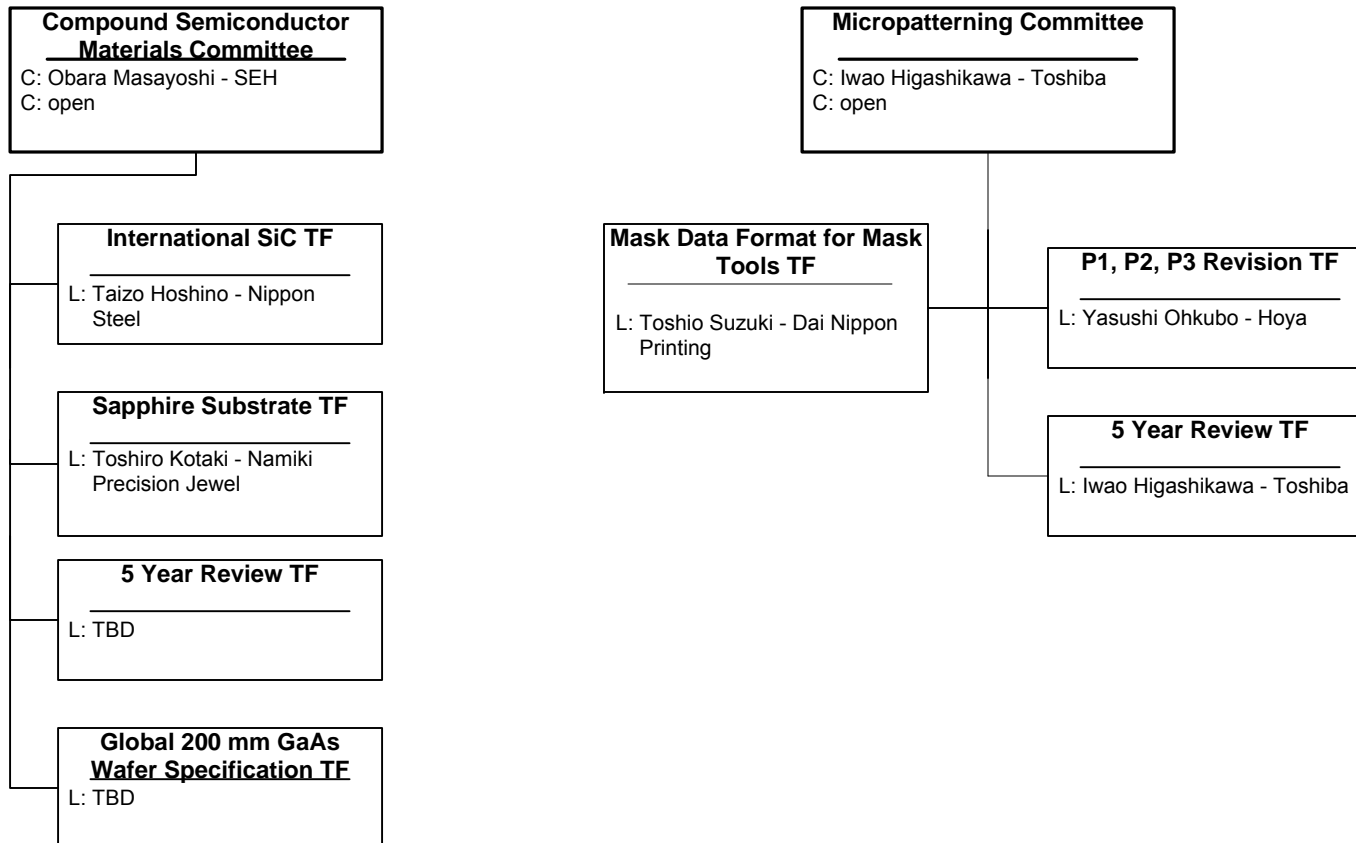
SEMI Japan FPD Factory Automation, Materials & Components, Mask, and Metrology Committees



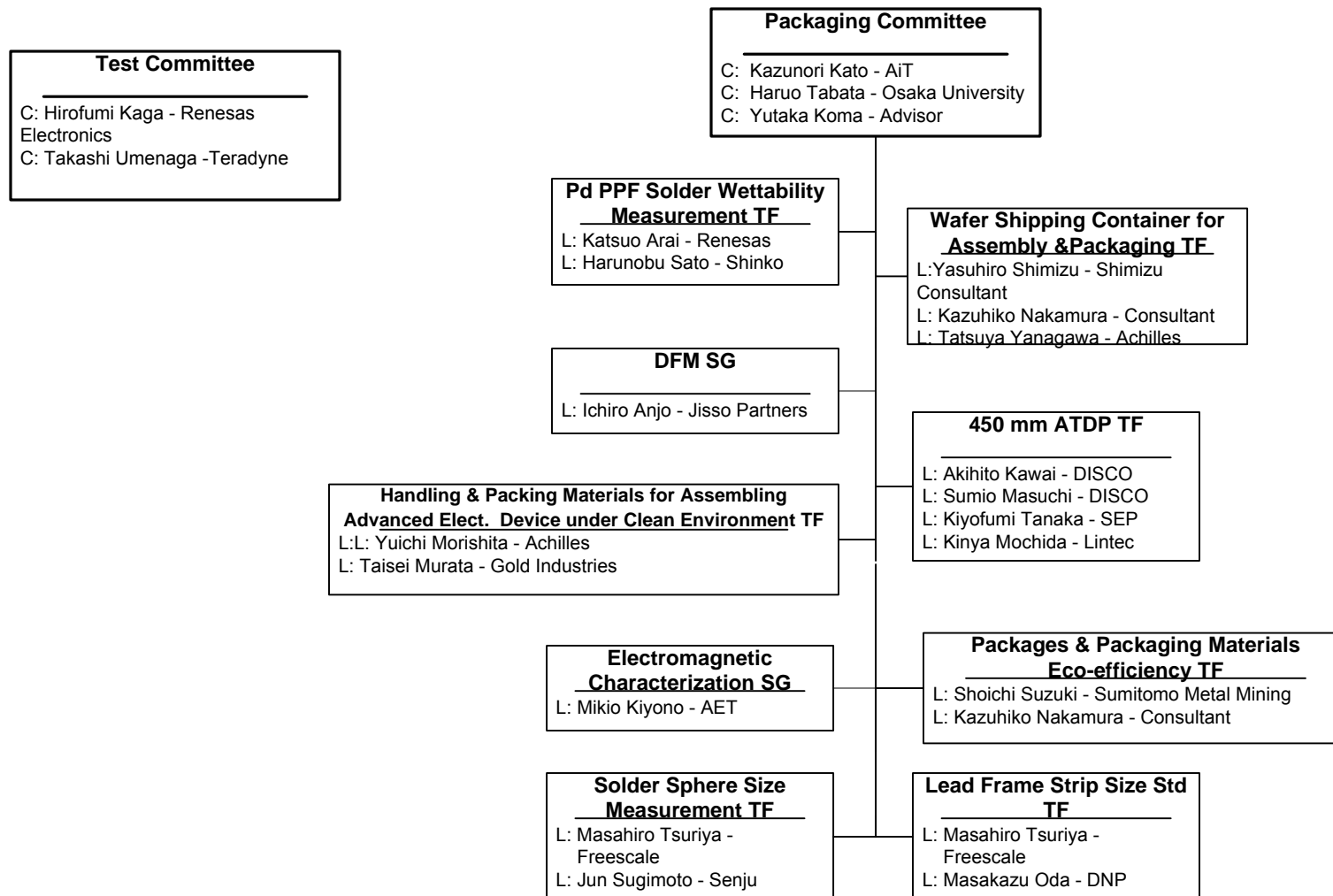
SEMI Japan Silicon Wafer Committee



SEMI Japan Compound and Micropatterning Committees



SEMI Japan Test and Packaging Committees



SEMI Korea Regional Standards Organization

Facilities Committee

C: Kwang Sun Kim - KUT
C: Insoo Cho - Shinsung ENG

Information & Control Committee

C: SeokGi Jeong - KC-Tech
C: Chul Hong Ahn - Hynix
C: Gun Woo Lee - Miracom Inc.

EHS WG

L: Seung Jong Ko - Hynix
L: Hyunsuk Kim - Samsung Electronics

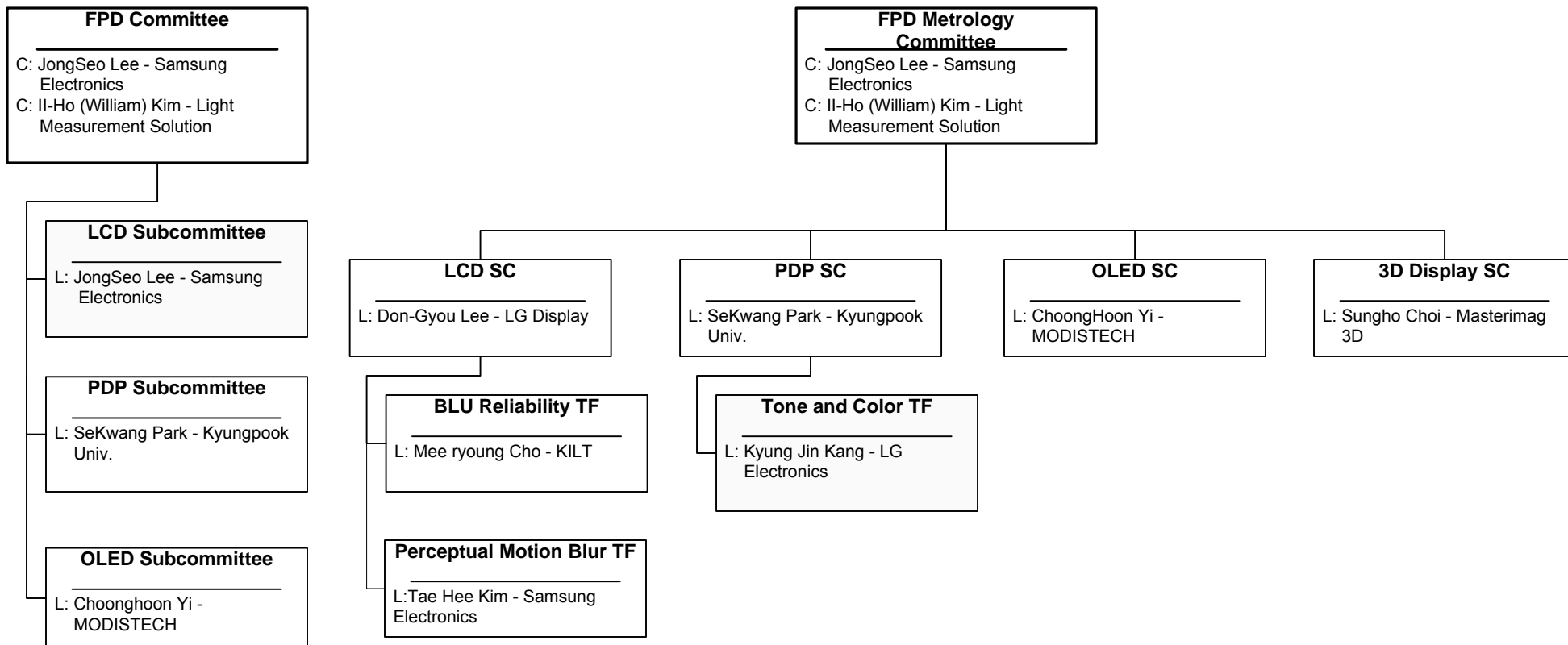
FPD Committee

C: JongSeo Lee - Samsung Electronics
C: Il-Ho (William) Kim - Light Measurement Solution

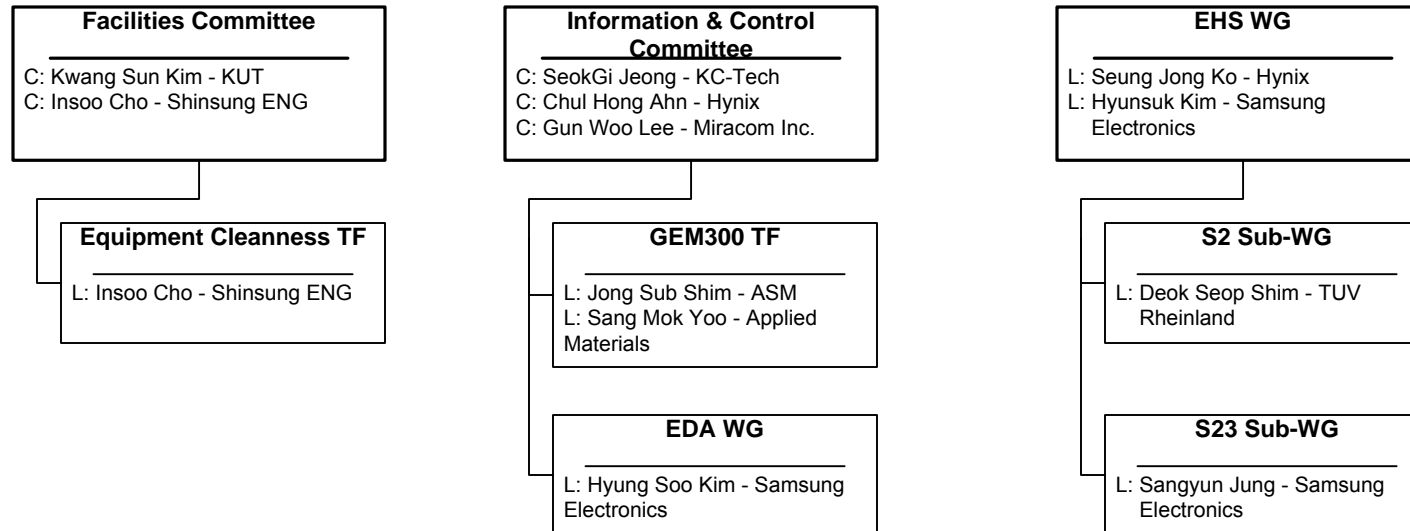
FPD Metrology Committee

C: JongSeo Lee - Samsung Electronics
C: Il-Ho (William) Kim - Light Measurement Solution

SEMI Korea FPD and FPD Metrology Committees



SEMI Korea Information & Control, Facilities Committees, and EHS WG



SEMI N.A. Regional Standards Organization

Co-Chairs: Jackie Ferrell - ISMI & Sean Larsen - Cymer

3DS-IC Committee

C: Andy Rudack - SEMATECH
C: Urmi Ray - Qualcomm
C: Chris Moore - Semilab
C: Sesh Ramaswami - Applied
Materials

Flat Panel Display Committee

C: Bill Colbran - Engenuity Systems

MEMS/NEMS Committee

C: Win Baylies - BayTech Group
C: Mark Crockett - MEMSmart

Silicon Wafer Committee

C: Dinesh Gupta - STA
C: Noel Poduje - SMS
VC: Win Baylies - BayTech Group

Automated Test Equipment Committee

C: Ajay Khoche - Consultant

Gases Committee

C: Tim Volin - Parker Hannifin

Metrics Committee

C: David Bouldin - Fab Consulting
C: Mark Frankfurth - Cymer

Traceability Committee

C: Win Baylies - BayTech Group
C: Yaw Obeng - NIST

Compound Semiconductor Materials Committee

C: Russ Kremer - Freiburger
Compound Materials
C: James Oliver - Northrop Grumman

HB-LED Committee

C: Iain Black - Philips
C: Chris Moore - Semilab
C: Bill Quinn - Veeco

Microlithography Committee

C: Wes Erck - Wes Erck &
Associates
C: Rick Silver - NIST

NA RSC Technical Architect Board

C: James Moyne - Applied Materials
C: Yaw Obeng - NIST

Environmental Health & Safety Committee

C: Chris Evanston - Salus
Engineering
C: Sean Larsen - Cymer
C: Eric Sklar - Safety Guru
C: James Beasley - ISMI

Information & Control Committee

C: Jack Ghiselli - Consultant
C: David Bricker - AMAT
C: Lance Rist - Consultant

Photovoltaic Committee

C: Win Baylies - Baytech Group

Facilities Committee

C: Phil Naughton - Applied Materials
C: Steve Lewis - CH2M Hill

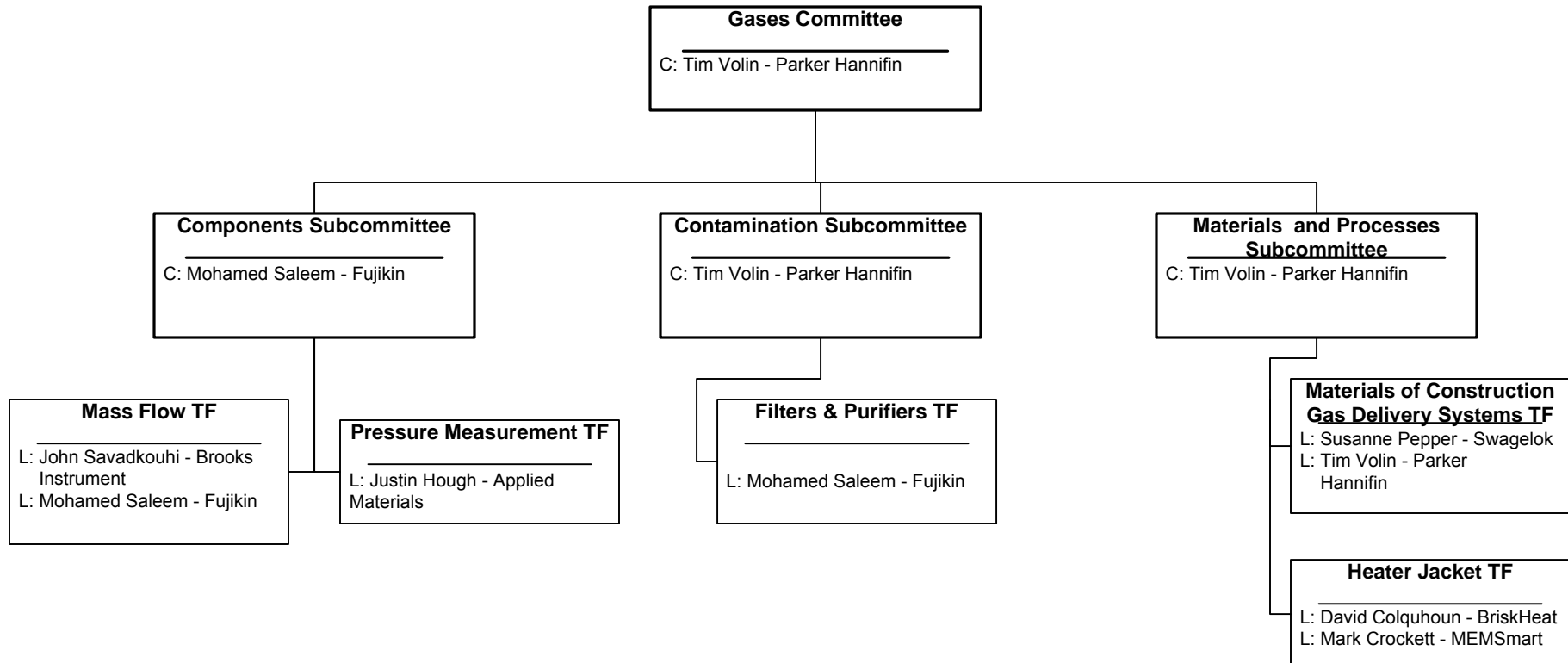
Liquid Chemicals Committee

C: Frank Flowers - FMC
C: Frank Parker - ICL

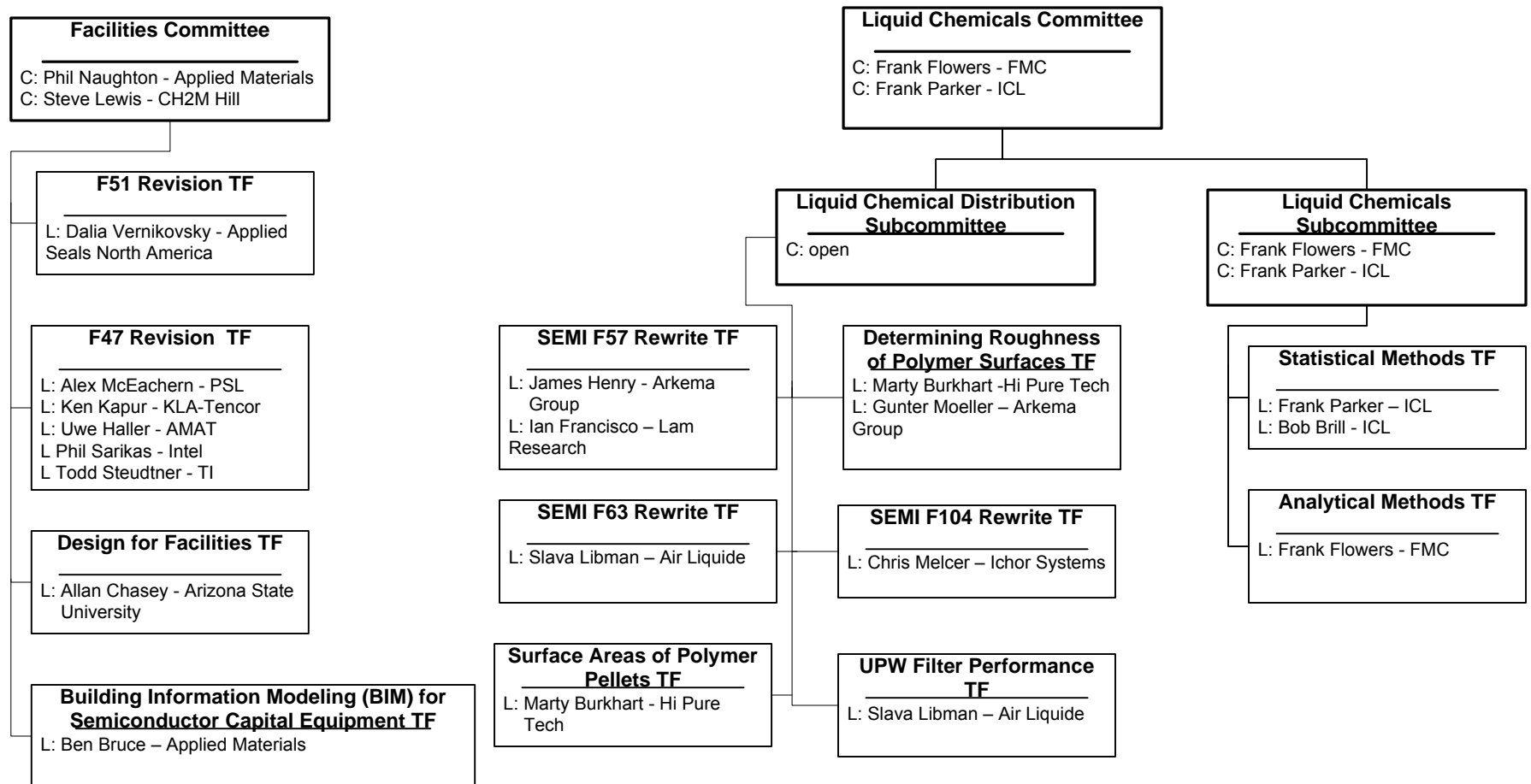
Physical Interfaces & Carriers Committee

C: Matt Fuller - Entegris
C: Mutaz Haddadin - Intel

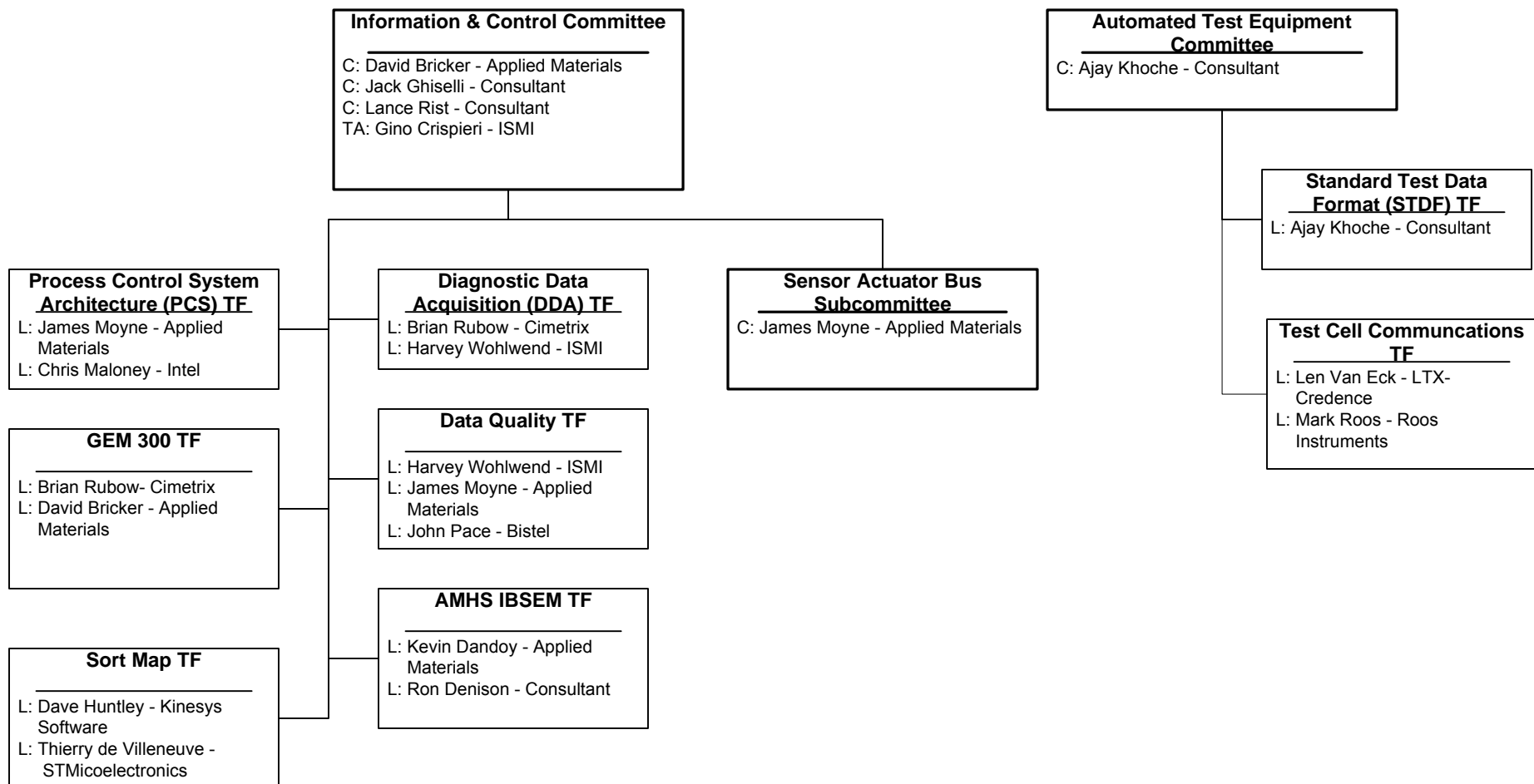
SEMI N.A. Gases Committee



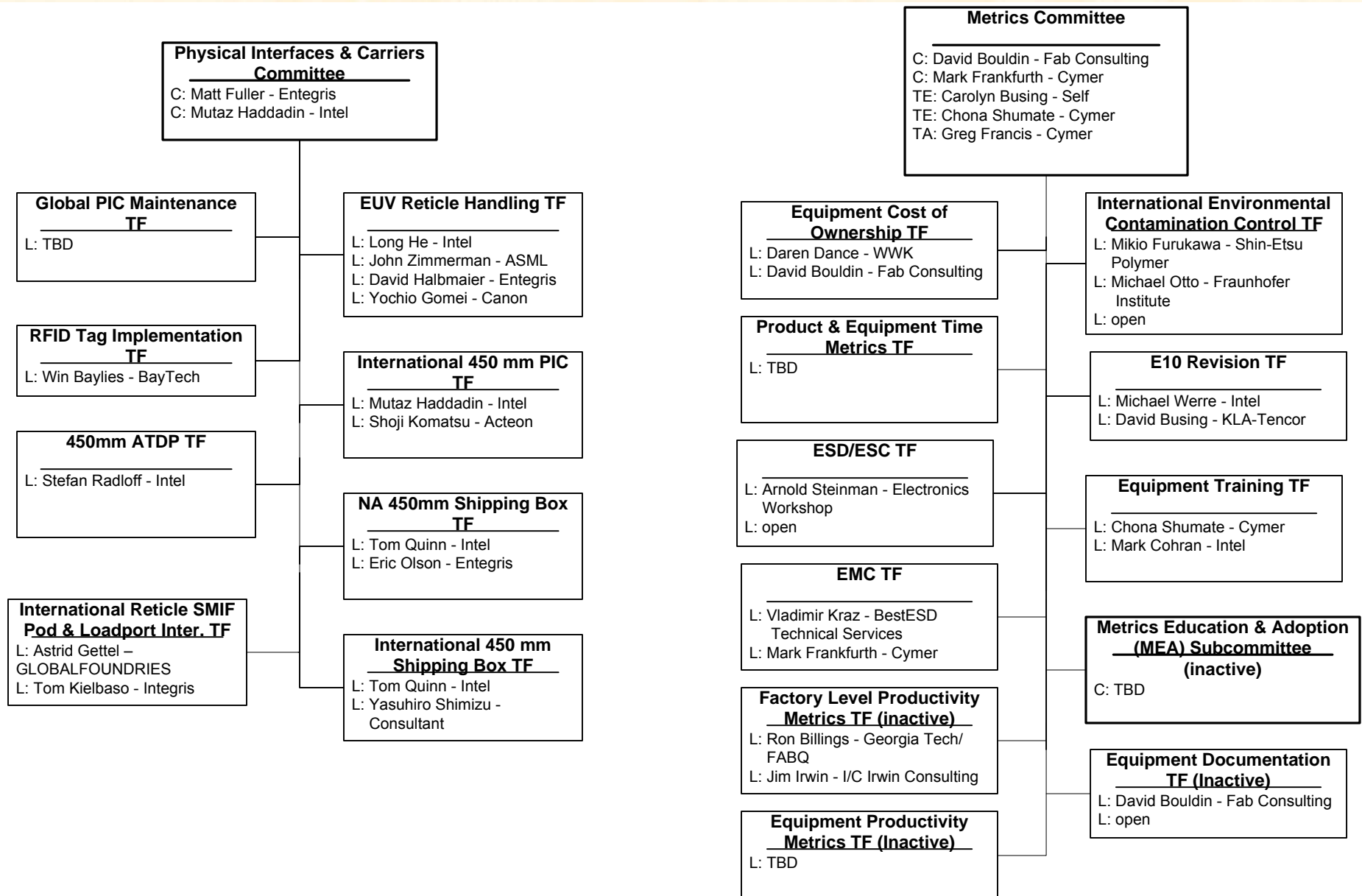
SEMI N.A. Facilities & Liquid Chemicals Committees



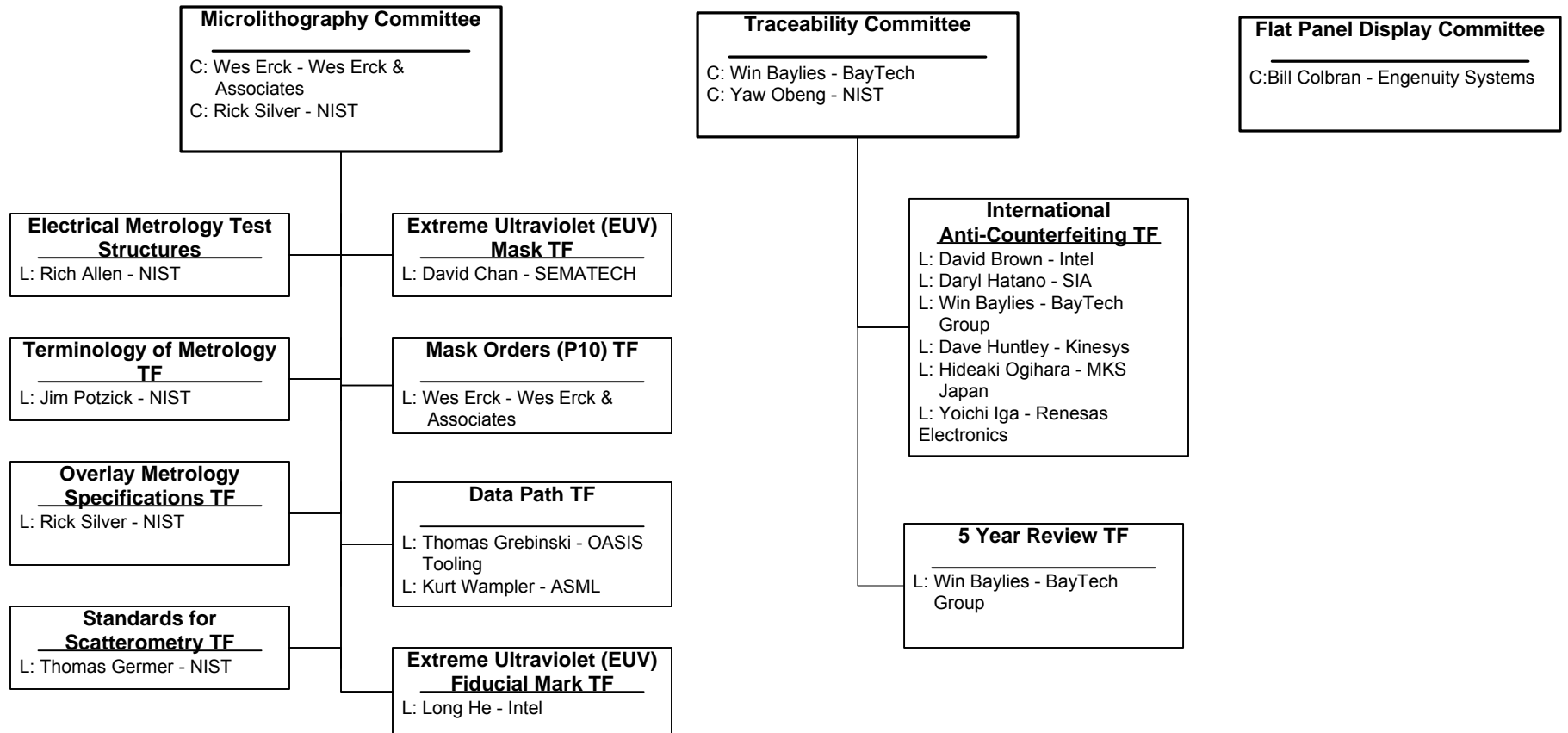
SEMI N.A. Information & Control and Automated Test Equipment Committees



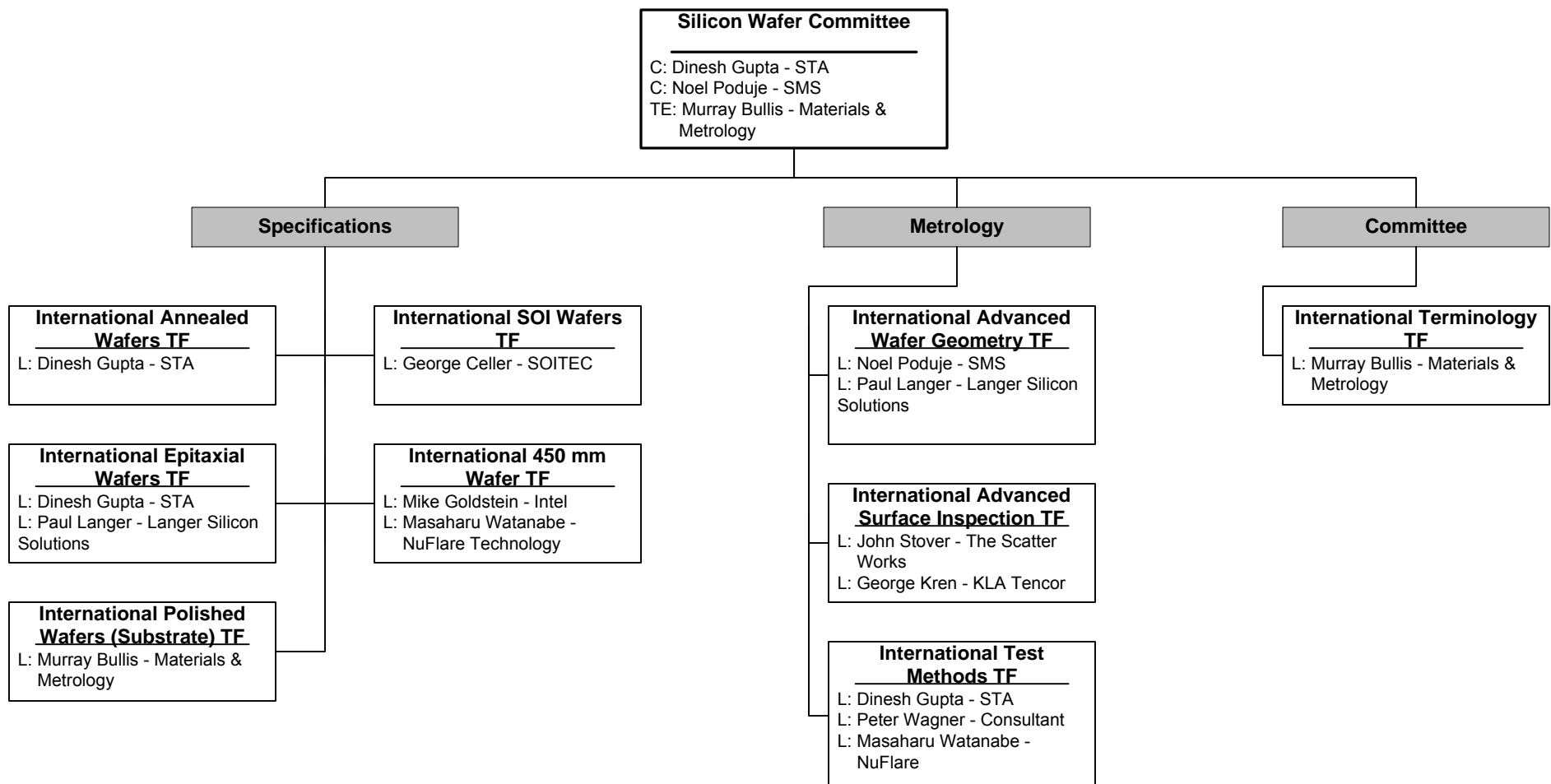
SEMI N.A. Physical Interfaces & Carriers and Metrics Committees



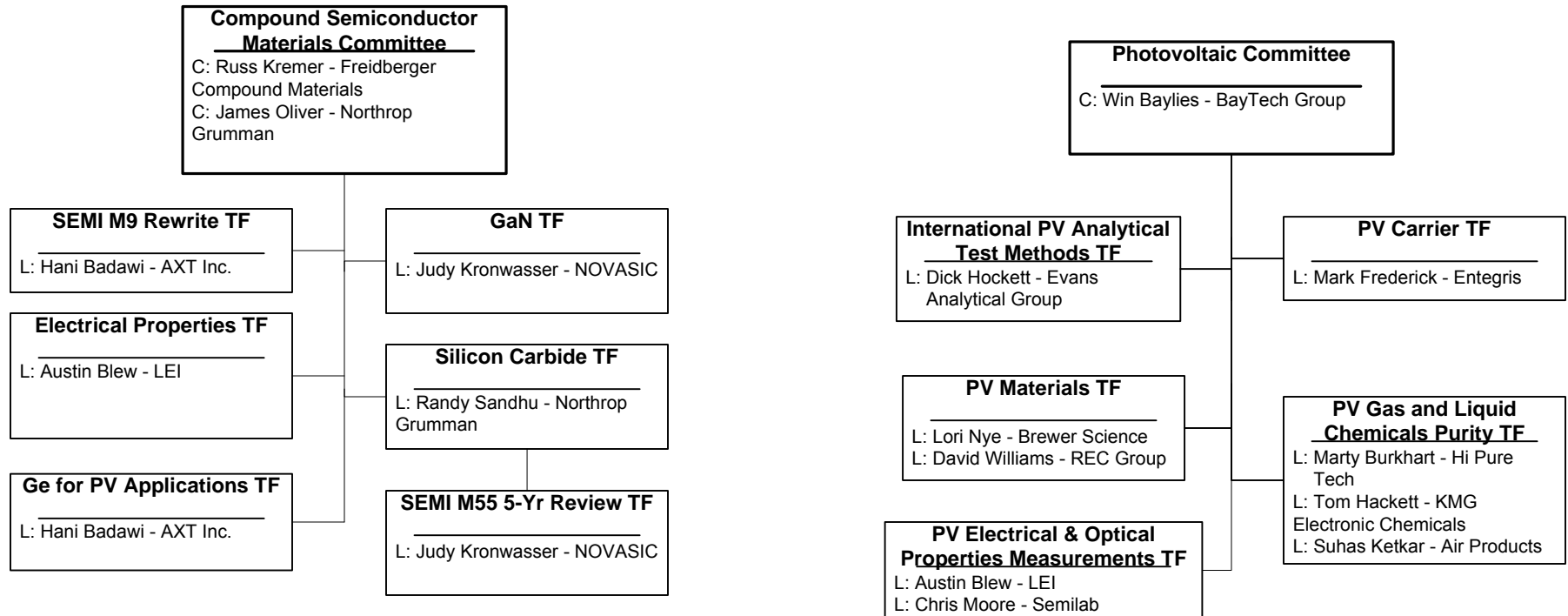
SEMI N.A. FPD, Microlithography & Traceability Committees



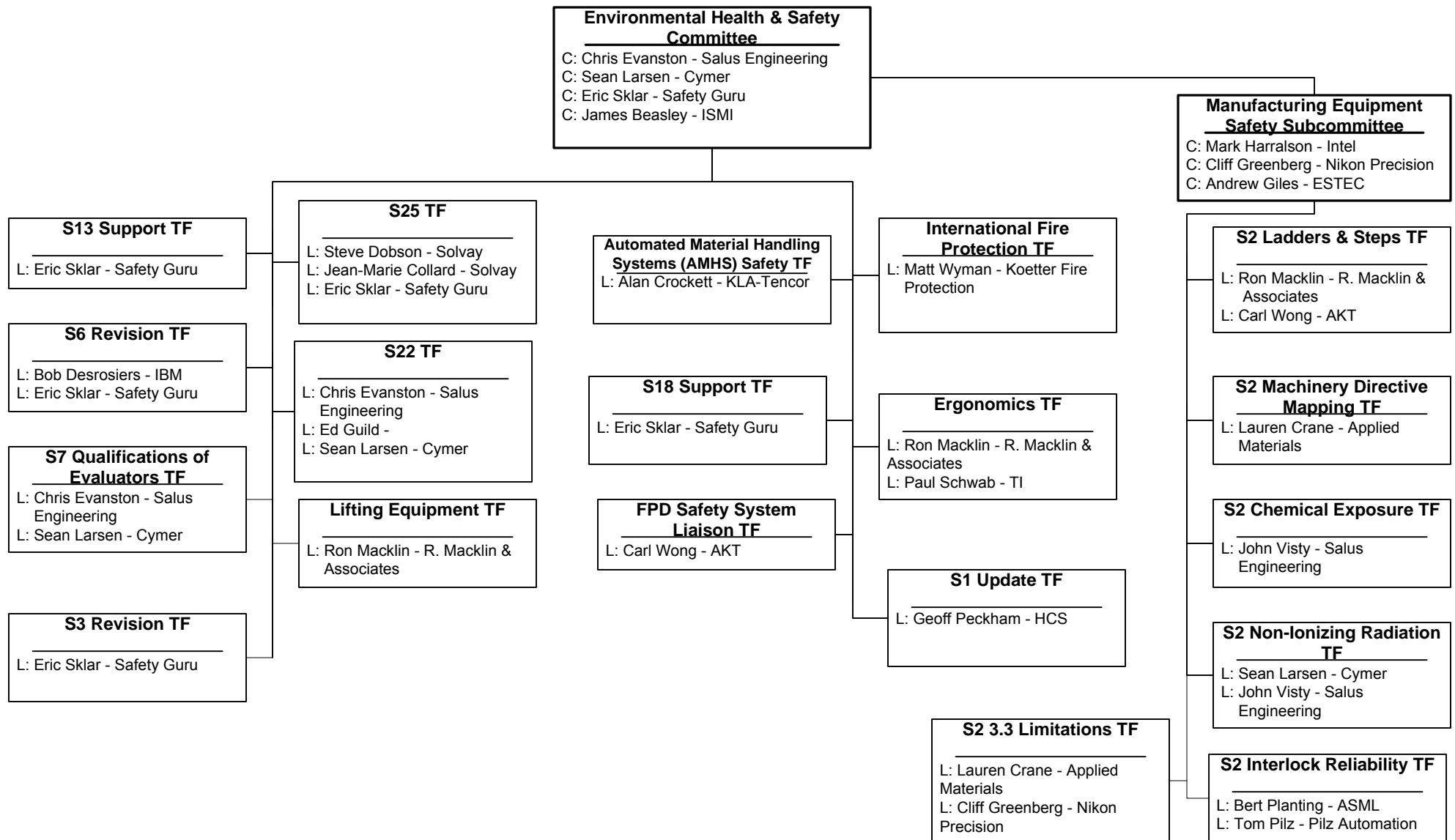
SEMI N.A. Silicon Wafer Committee



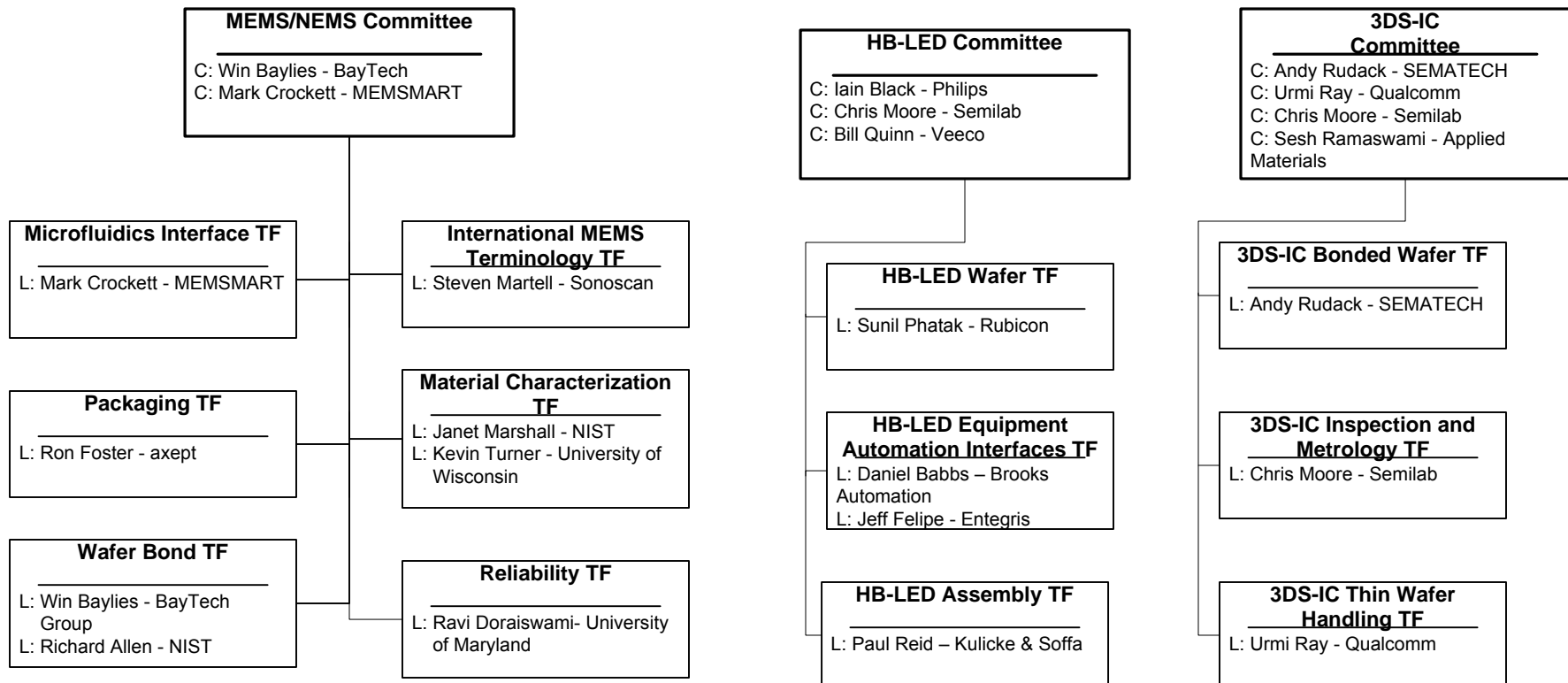
SEMI N.A. Compound Semiconductor & Photovoltaic Committees



SEMI N.A. Environmental, Health & Safety Committee



SEMI N.A. 3DS-IC, HB-LED & MEMS/NEMS



SEMI Taiwan Regional Standards Organization

ISC Taiwan Advisor

Tzeng-Yow Lin - CMS/ITRI

**Information & Control
Committee**

C: Robert Chien - TSMC

**Environmental Health & Safety
Committee**

C: S. W. Yu - SAHTECH
C: F. M. Hsu - TSMC

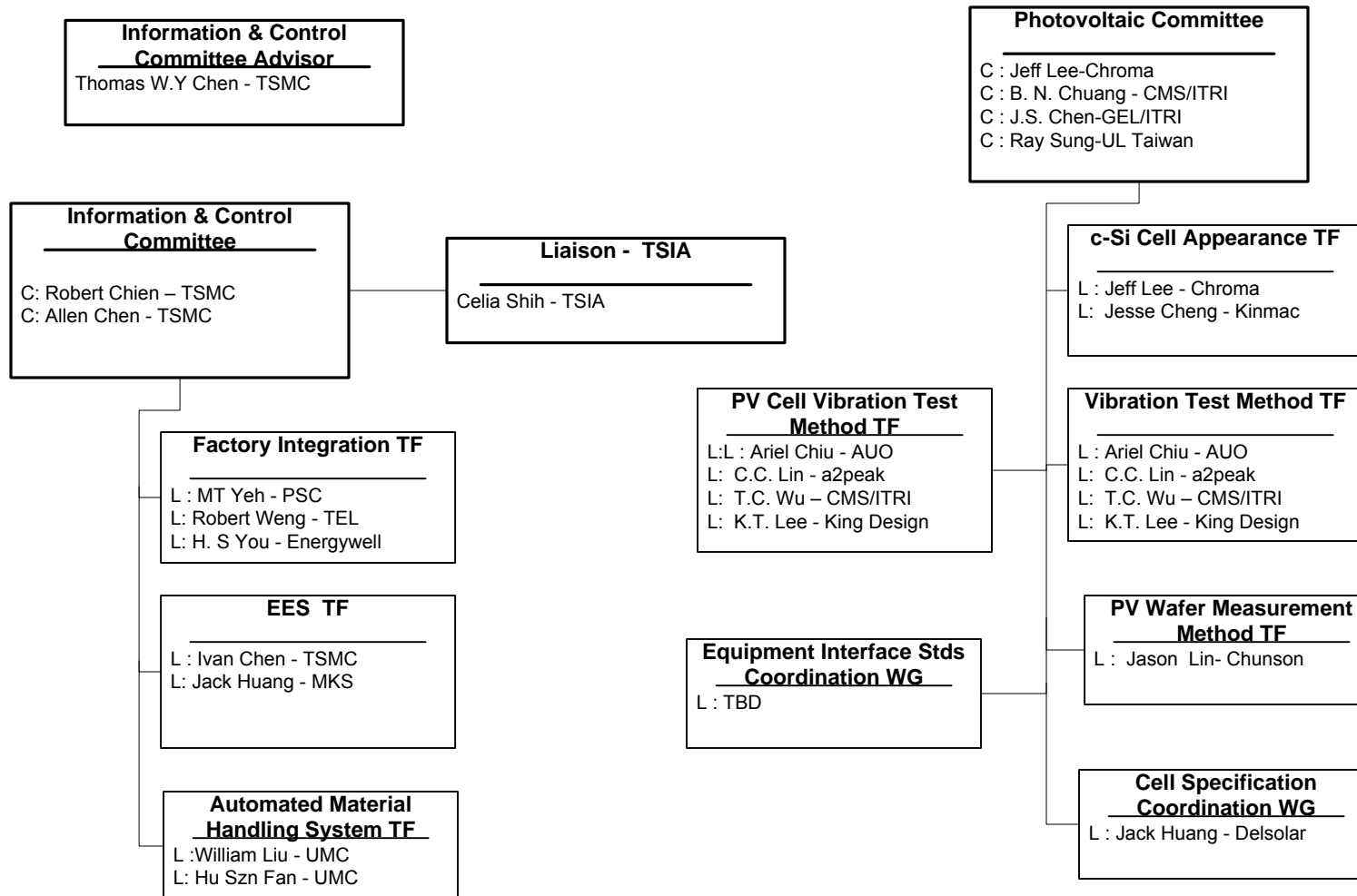
Flat Panel Display Committee

C: Tzeng-Yow Lin - CMS/ITRI
C: Jia-Ming Liu - TDMDA

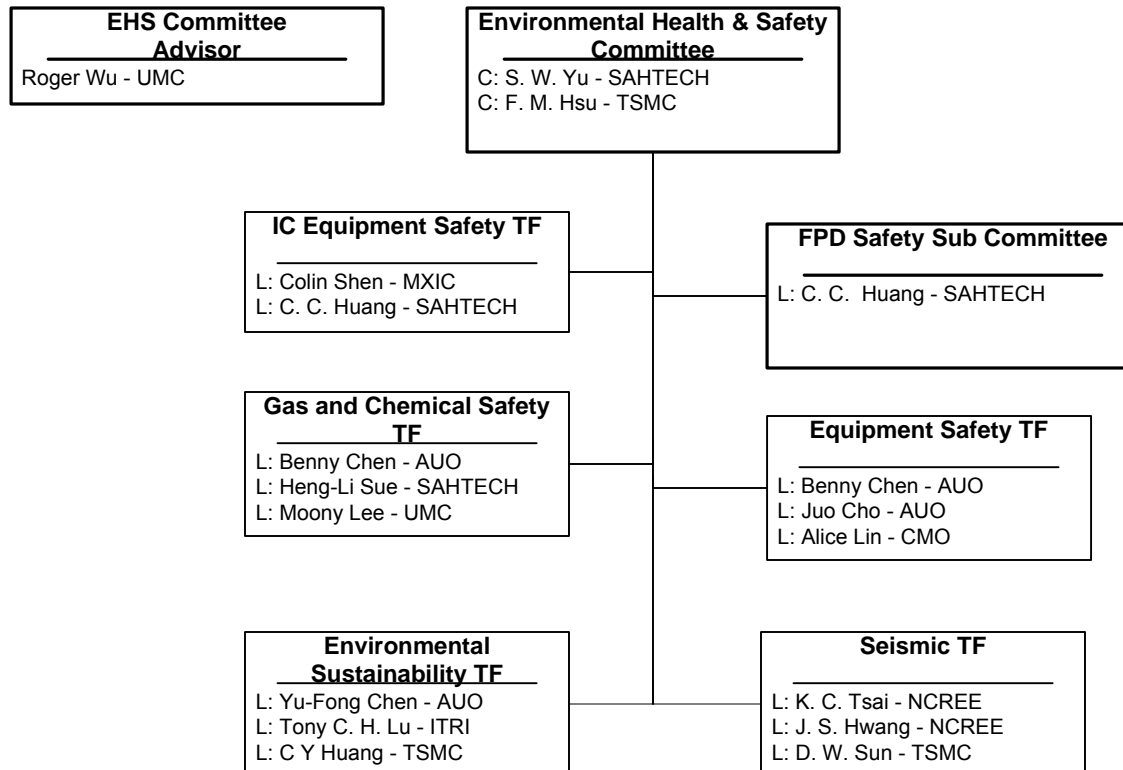
Photovoltaic Committee

C : Jeff Lee-Chroma
C : B. N. Chuang - CMS/ITRI
C : J.S. Chen-GEL/ITRI
C : Ray Sung-UL Taiwan

SEMI Taiwan Information & Control and Photovoltaic Committees



SEMI Taiwan Environmental, Health & Safety Committee



SEMI Taiwan Flat Panel Display Committee

